

Response under 37 C.F.R. 1.116
Expedited Procedure
Examining Group (1792)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hongqin Shi

Art Unit: 1792

Serial No.: 10/666,671 (8251)

Examiner: Vinh, Lan

Filed: 17 September 2003

Docket No. TI-62961

For: METHODS AND APPARATUS OF ETCH PROCESS CONTROL IN
FABRICATIONS OF MICROSTRUCTURES

RESPONSE UNDER 37 C.F.R. § 1.111

10 August 2009

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Madam:

In response to the Examiner's Action dated 10 June 2009 applicant responds as follows: